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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Takeshi
Nogami, et al.

Application No. 10/775,935

Filed: February 10, 2004

For: SEMICONDUCTOR
MANUFACTURING APPARATUS AND
METHOD FOR MANUFACTURING
SEMICONDUCTOR DEVICES

Group Art Unit: To be assigned

Examiner: To be assigned

CERTIFICATE OF MAILING

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Suzarah Guevara

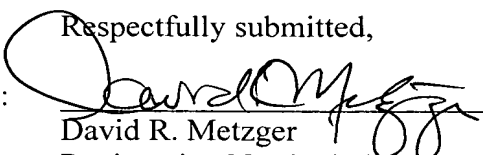
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STATUS INQUIRY

Sir:

With regard to the above-identified patent application that was filed in the U.S. Patent and Trademark Office on February 10, 2004, U.S. Serial No. 10/775,935, we have not yet received any communication from the U.S. Patent Office since issuance of the Filing Receipt which was dated May 7, 2004. At this time, we respectfully request the current status of this application.

Dated: December 2, 2005

Respectfully submitted,
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